



AF/1762
[10191/1728]

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Inventors : GROSSE et al. Confirmation No.: 9967
Serial No. : 09/831,722
Filed : September 6, 2001
For : DEVICE AND METHOD FOR PRODUCING A
LOCAL PLASMA THROUGH MICROSTRUCTURE
ELECTRODE DISCHARGES USING MICROWAVES

Examiner : E. Fuller
Art Unit : 1762
Customer No. : 26646

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
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Date 11/2/05

Atty's Reg. # 41,172

Atty's Signature

LS Magist
DERVIS MAGISTRE
KENYON & KENYON

AMENDMENT TRANSMITTAL

SIR:

Please find an Amendment transmitted herewith for filing in the
above-identified patent application. Applicants respectfully request a three-month
extension of time in which to respond to the office action dated May 31, 2005, for
which a response period expiring on August 31, 2005 was set. The extended period
expires on November 30, 2005.

Please charge the \$1,020.00 extension fee and any additional fees
required to Deposit Account No. 11-0600. A duplicate copy of this Transmittal is
enclosed.

Respectfully submitted,

KENYON & KENYON

By: LS Magist (R. No. 41,172)

Dated: 11/2/05

By: G. A. Messina
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